

00684.002700.1

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Yasuyuki UNNO

Application No.: 09/523,735

Filed: March 13, 2000

For: PROJECTION OPTICAL SYSTEM AND  
PROJECTION EXPOSURE APPARATUS  
HAVING THE SAME

Examiner: P. Kim

Group Art Unit: 2851

October 28, 2002

Commissioner for Patents  
Washington, D.C. 20231

TECHNOLOGY CENTER 2800

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SUPPLEMENTAL REQUEST FOR APPROVAL OF DRAWING CHANGES

Sir:

Further to the Request for Approval to Amend the Drawings filed on October 30, 2000, Applicant requests that the Examiner approve the changes to Figures 3 and 29, as shown in red on the attached sketches, enclosed in duplicate.

In Figure 3, on the axis of the abscissa, change "P(r,Q)" to -- P(r,θ) --, as shown.

In Figure 29, change reference numeral "4" to -- 104 --, as shown.

Favorable consideration is requested.

#14  
10-31-02  
APP

drawing  
approved  
10/11/02

Applicant's undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010 All correspondence should continue to be directed to our address given below.

Respectfully submitted,



Attorney for Applicant

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